Semiconductor devices - Micro-electromechanical ACT. devices -- Part 19: Electronic compasses



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Euroopa standardimisorganisatsioonid on teinud	Date of Availability of the European standard is
Euroopa standardi rahvuslikele liikmetele	27.09.2013.
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#### EN 62047-19

## NORME EUROPÉENNE EUROPÄISCHE NORM

September 2013

ICS 31.080.99

English version

# Semiconductor devices Micro-electromechanical devices Part 19: Electronic compasses

(IEC 62047-19:2013)

Dispositifs à semiconducteurs – Dispositifs microélectromécaniques -Partie 19: Compas électroniques (CEI 62047-19:2013) Halbleiterbauelemente -Bauelemente der Mikrosystemtechnik -Teil 19: Elektronische Kompasse (IEC 62047-19:2013)

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#### **Foreword**

The text of document 47F/156/FDIS, future edition 1 of IEC 62047-19, prepared by SC 47F "Microelectromechanical systems" of IEC/TC 47 "Semiconductor devices" was submitted to the IEC-CENELEC parallel vote and approved by CENELEC as EN 62047-19:2013.

The following dates are fixed:

•	latest date by which the document has to be implemented at national level by publication of an identical national standard or by endorsement	(dop)	2014-05-21
•	latest date by which the national standards conflicting with the document have to be withdrawn	(dow)	2016-08-21

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to be &
(SO 11606 (f.) In the official version, for Bibliography, the following note has to be added for the standard indicated:

EN ISO 11606 NOTE Harmonized as ISO 11606 (not modified).

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# SEMICONDUCTOR DEVICES – MICRO-ELECTROMECHANICAL DEVICES –

#### Part 19: Electronic compasses

#### 1 Scope

This part of IEC 62047 defines terms, definitions, essential ratings and characteristics, and measuring methods of electronic compasses. This standard applies to electronic compasses composed of magnetic sensors and acceleration sensors, or magnetic sensors alone. This standard applies to electronic compasses for mobile electronic equipment.

For marine electronic compasses, see ISO 11606.

Electronic compasses are called "e-compasses" for short. Types of e-compasses are: 2-axis e-compasses, 3-axis e-compasses, 6-axis e-compasses, etc., all of which are covered by this standard.

#### 2 Normative references

The following documents, in whole or in part, are normatively referenced in this document and are indispensable for its application. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

None

#### 3 Terms and definitions

For the purposes of this document, the following terms and definitions apply.

#### 3.1

#### 3-axis Helmholtz coil

three Helmholtz coils that generate magnetic fields at right angles to each other

#### 3.2

#### zero magnetic field environment

magnetic field environments where magnetic field strength in a space including a device under test is lower than the strength specified

Note 1 to entry: The device under test (DUT) is defined in 4.1.7.

#### 3.3

#### e-compass

electronic compass

compass that calculates and outputs an azimuth using the electrical output of sensors

Note 1 to entry: The term "e-compass" is used as an abbreviated term of electronic compass. (See the above Scope.)

#### 3.4

#### 2-axis e-compass

e-compass that uses a 2-axis magnetic sensor as a geomagnetism detection element